

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Serial Number: 09/891,511

Examiner: Jack I. Berman

Filed: June 27, 2001

Confirmation Number: 8779

For:

INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF MANUFACTURING DEVICES USING THE SYSTEM

Attorney Docket Number:

010819

Customer Number:

38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 January 25, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 25, 2005 for 2 months from November 25, 2005 to January 25, 2006.

Attached please find a check in the amount of \$450.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Attorney for Applicants

Registration No. 56,171 Telephone: (202) 822-1100

Facsimile: (202) 822-1111

MJC/mra

01/26/2006 HALIII 00000119 09891511

01 FC:1252

450.00 OP